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IAP20 Rec'd PCT/PTO 10 JAN 2006

ATTORNEY DOCKET NO: 72099

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : BLATTNER et al.
PCT No. : PCT/CH2004/000428
Confirm. No. : N/A
Filed : January 10, 2006
For : DEVICE FOR STORING...
Art Unit : N/A
Examiner : N/A
Dated : January 10, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

The following references have been cited in the International Phase of the above-identified application.

- Patent Abstracts of Japan vol. 2003, no. 11 and JP 2003 188243 discloses a wafer support. The reference has been cited under Category X as being relevant to International claims 1 and 5 - 7 and further cited under Category A as being relevant to International claims 2 - 4 and 8 - 19. No full translation is available at this time, however, attached is an English language abstract.

- Patent Abstracts of Japan vol. 2002, no. 08 and JP 2002 110577 discloses a vertical reactor. The reference has been cited under Category X as being relevant to International claim 1 and further cited under Category A as being relevant to International claims 2 - 19. No full translation is available at this time, however, attached is an English language abstract.

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- WO 97/20341 discloses a thermal processing apparatus and process. The reference has been cited under Category X as being relevant to International claim 1 and further cited under CATEGORY A as being relevant to International claims 2 - 19.

- U.S. Patent 5,534,074 discloses a vertical boat for holding semiconductor wafers. The reference has been cited under CATEGORY X as being relevant to International claim 1 and further cited under CATEGORY A as being relevant to International claims 2 - 19.

Consideration of the above references is requested.

Respectfully submitted
for Applicant,

By: 
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McGLEW AND TUTTLE, P.C.

JJM:tf
72099.5

Enclosed: PTO-1449 Form
copy of International Search Report
copies of (3) References

DATED: January 10, 2006
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SHOULD ANY OTHER FEE BE REQUIRED, THE PATENT AND TRADEMARK OFFICE IS HEREBY REQUESTED TO CHARGE SUCH FEE TO OUR DEPOSIT ACCOUNT 13-0410.

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS EXPRESS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, NO.: EV435294218US

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Form PTO-1449

U.S. Department of Commerce Sheet 1 of 1
Patent and Trademark OfficeLIST OF REFERENCES CITED
BY APPLICANT
(Use several sheets if necessary)Atty Docket No.: 72099
PCT No.: PCT/CH2004/000428
Applicant: BLATTNER et al.

U.S. PATENT DOCUMENTS

Ex- aminer Initial	Document No.	Date	Name	Class	Sub- class	Filing Date
	<u>5,534,074</u>	<u>July 9, 1996</u>	<u>Koons</u>			<u>May 17, 1995</u>

FOREIGN PATENT DOCUMENTS

Ex- aminer Initial	Document No.	Date	Country	Class	Sub- class	Translation Yes/No
	<u>JP 2003 188243</u>	<u>July 4, 2003</u>	<u>Japan</u>			<u>No</u>
	<u>JP 2002 110577</u>	<u>April 12, 2002</u>	<u>Japan</u>			<u>No</u>
	<u>WO 97/20341</u>	<u>June 5, 1997</u>	<u>International</u>			<u>Yes</u>

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

Ex- aminer Initial	Author	Date	Title	Textbook in	Translation Yes/No

Examiner_____
Date Considered